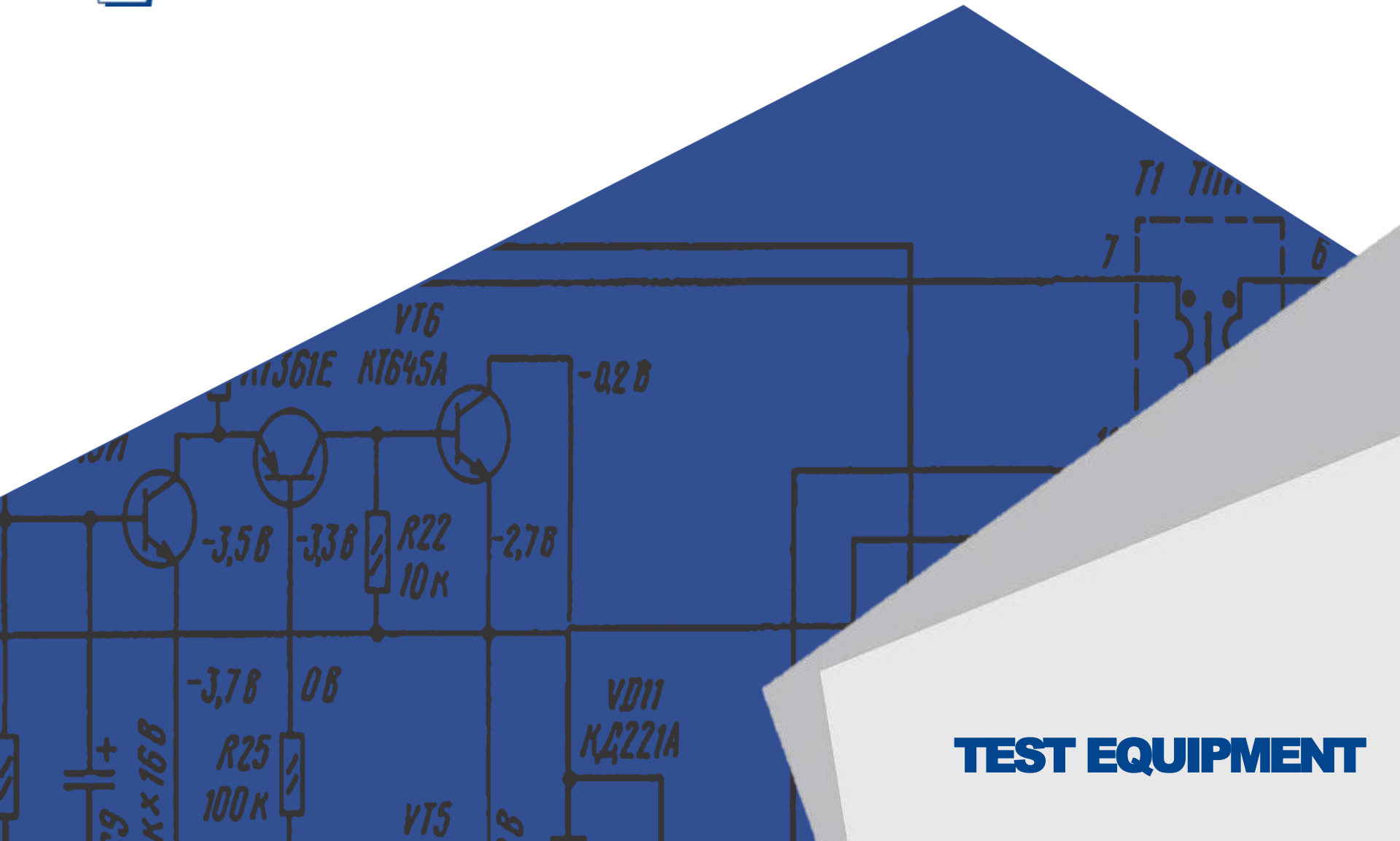




PROTON-ELECTROTEX



TEST EQUIPMENT

Quick facts

Automation laboratory

- ❑ Founded in 2011 to provide parent company with reliable Hi-End test equipment
- ❑ Located in Moscow
- ❑ From **Design** to **Production** to **Installation** to **Technical Support** and **Modernization**
- ❑ Multifunctional team of hi-qualified developers
- ❑ Main modern approaches to development are implemented: SCRUM, FMEA, TRIZ

Test equipment family

Bipolar Static Testers

up to 26kA, up 8500V

Bipolar Dynamic Testers

ATU, CROVU, Q_{rr} tq, TOU

Surge Current Testers

up to 120kA

Power Cycling Testers

Clamping Systems

up to 150kN

Z_{th} testers

Under development

HTRB Testers

IGBT Static Testers

up to 13kA, up 8500V

Late stage development

IGBT Dynamic Testers

up to 15kA, up 3400V

Prototype

Full SiC MOSFET Testers

Static & Dynamic

Under development

Stray Inductance Testers

Under development

Main advantages



Modular design

- ✓ High maintainability
- ✓ Flexibility
- ✓ Easy update and modernization



All tests in one process

- ✓ “All tests in one clamping”
- ✓ High performance
- ✓ Minimization of human factor



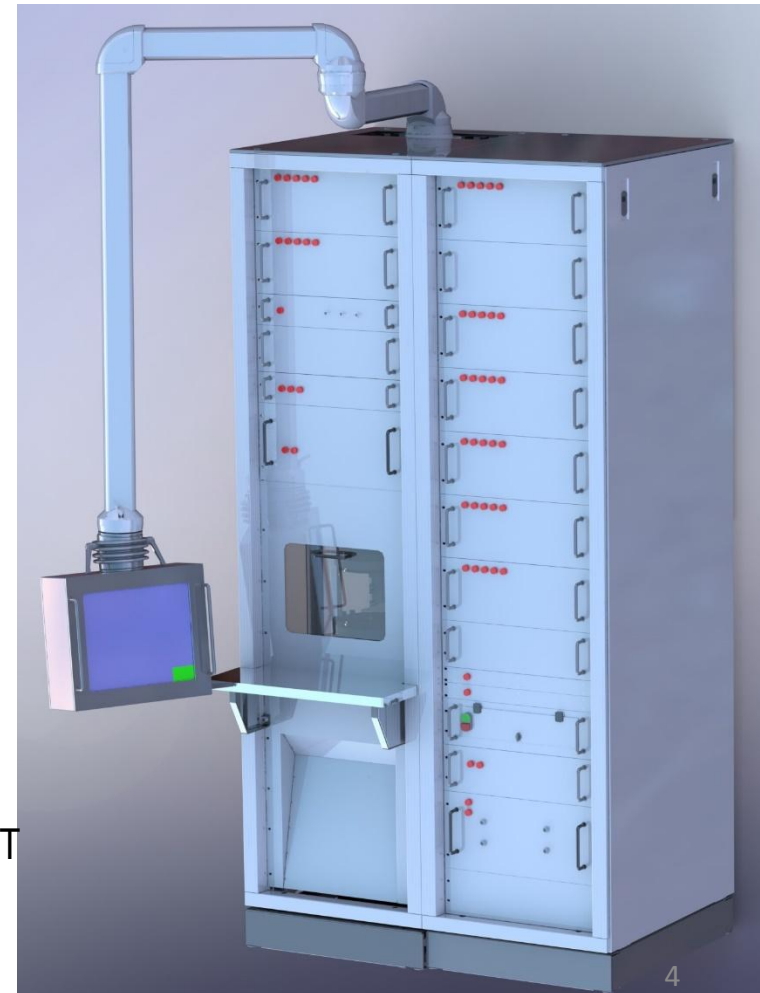
High accuracy

- ✓ Automatic calibration
- ✓ High accuracy



Servo controlled pulse generation

- ✓ High test condition stability independent from DUT
- ✓ Wide measurement range
- ✓ Servo controlled signals



Bipolar Static Test Equipment

Characteristic	Designator	Range		Accuracy	Conditions
Peak on-state voltage, V	$V_{TM(FM)}$	0.3	5	$\pm 0.5\%$ of reading $\pm 5mV$	$I_{TM(FM)} = 400..25200A$; Signal shape: trapezoidal, sinus, s-curve Duration up to 10ms
Repetitive peak off-state voltage, Repetitive peak reverse voltage, V	V_{DRM}, V_{RRM}	100	8000	$\pm 1\%$ of reading $\pm 10V$	$I_{DRM/RRM} = 0.1..300mA$; Signal shape: sinus, DC Duration 8.3..10ms Frequency 5 / 50Hz
Repetitive peak off-state current, Repetitive peak reverse current, mA	I_{DRM}, I_{RRM}	0.1	10	$\pm 1\%$ of reading $\pm 10\mu A$	$V_{DRM/RRM} = 100..8000V$; Signal shape: sinus, DC Duration 8.3..10ms Frequency 5 / 50Hz
		10	100	$\pm 1\%$ of reading $\pm 0.1mA$	
		100	300	$\pm 1\%$ of reading $\pm 1mA$	
Gate trigger direct voltage, V	V_{GT}	0.1	4.5	$\pm 2\%$ of reading $\pm 10mV$	$V_D = 12V$;
Gate trigger direct current, mA	I_{GT}	50	1000	$\pm 2\%$ of reading $\pm 1mA$	$V_D = 12V$;
Holding current, mA	I_H	30	1000	$\pm 2\%$ of reading $\pm 1mA$	$I_G = 1A$;
Isolation test voltage, V	$V_{ISOLAC(RMS)}$	100	10000	$\pm 1\%$ of reading $\pm 10V$	$I_{ISOL} = 0.1..5mA$;
	V_{ISOLDC}	100	12000	$\pm 1\%$ of reading $\pm 10V$	
Isolation resistance, MOhm	R_{ISOL}	5	1000	$\pm 1\%$ of reading $\pm 1MOhm$	$V_{ISOL} = 1000..2500V$;

Bipolar Dynamic Test Equipment

Characteristic	Designator	Range		Accuracy	Conditions
Critical rate of rise of off-state voltage, V/us	dV_D/dt	50	2500	±10%	$V_{DM} = 300..4500V$ $t = 50..200\mu s$
Reverse recovery charge, uQ	Q_{RR}	1	10000	According to the oscilloscope accuracy and resolution*	$I_{TM(FM)} = 100..500 (2000)A$ $dl/dt = 1..100A/us$ $V_R = 100V$
Reverse recovery time, us	t_{RR}	1	100	According to the oscilloscope accuracy and resolution*	$I_{TM(FM)} = 100..500 (2000)A$ $dl/dt = 1..100A/us$ $V_R = 100V$
Reverse recovery current, A	I_{RRM}	10	500 (2000)	±1.25% ±0.1A	$I_{TM(FM)} = 100..500 (2000)A$ $dl/dt = 1..100A/us$ $V_R = 100V$
Turn-off time, us	t_Q	1	2000	According to the oscilloscope accuracy and resolution*	$I_{TM(FM)} = 100..500 (2000)A$ $dl/dt = 1..100A/us$ $V_R = 100V$ $V_D = 100..2000V$ $dV/dt = 20..200V/us$
Peak reverse power, kW	P_{RSM}	1	70	±5% ±0.1kW	$I_{PRSM} = 0.2..60 A$;
Avalanche voltage, V	V_{BR}	100	9000	±4% ±10V	-
Gate controlled turn-on time, us	t_{gt}	0.5	30	±3% ±100ns	-
Gate controlled delay time, us	t_d	0.5	30	±3% ±100ns	-

* Scope device specification:
 14 bit (0.006 %) resolution (16 bit enhanced resolution)
 500 MS/s sampling
 250 MHz bandwidth

32 MSamples memory per channel
 0.25 % DC vertical accuracy, 0.1 % typical
 25 ppm time base accuracy

IGBT Static Test Equipment

Characteristic	Designator	Range		Accuracy	Conditions
Gate-to-Emitter Leakage Current, μA	I_{GES}	1	1 000	$\pm 1\%$ of reading $\pm 1\mu\text{A}$	$V_{\text{GE}} = 15\text{V}..40\text{V}$; $V_{\text{CE}} = 0\text{V}$
Gate Threshold Voltage, V	$V_{\text{GE(on)}}$	4	10	$\pm 1\%$ of reading $\pm 10\text{mV}$	$I_{\text{C}} = 10..1000\text{mA}$; $V_{\text{CE}} = V_{\text{GE}}$;
Collector-to-Emitter Leakage Current, μA	I_{CES}	0.1	1 000	$\pm 1\%$ of reading $\pm 10\mu\text{A}$	$V_{\text{GE}} = 0\text{V}$; $V_{\text{CE}} = 100..8500\text{V}$; Signal shape: half-sine, DC
		1 000	300 000	$\pm 1\%$ of reading $\pm 1\text{mA}$	
Collector-to-Emitter Breakdown Voltage, V	$V_{(\text{BR})\text{CES}}$	100	8000	$\pm 1\%$ of reading $\pm 10\text{V}$	$V_{\text{GE}} = 0\text{V}$; $I_{\text{C}} = 100\text{nA}..300\text{mA}$; Signal shape: half-sine, DC
Collector-to-Emitter Saturation Voltage, V	$V_{\text{CE(on)}}$	0.2	10	$\pm 1\%$ of reading $\pm 10\text{mV}$	$I_{\text{C}} = 200..12600\text{A}$; $V_{\text{GE}} = 10..20\text{V}$; Signal shape: trapezoidal, sinus, s-curve
Max Reverse Leakage Current, μA	I_{R}	10	1 000	$\pm 1\%$ of reading $\pm 10\mu\text{A}$	$V_{\text{BR}} = 100..8000\text{V}$; Signal shape: half-sine, DC
		1 000	300 000	$\pm 1\%$ of reading $\pm 1\text{mA}$	
Cathode Anode Breakdown Voltage, V	V_{BR}	100	8000	$\pm 1\%$ of reading $\pm 10\text{V}$	$I_{\text{C}} = 0..10\text{mA}$; Signal shape: half-sine, DC
Forward Voltage, V	V_{F}	0.2	10	$\pm 1\%$ of reading $\pm 10\text{mV}$	$I_{\text{C}} = 200..5000\text{A}$; Signal shape: trapezoidal, sinus, s-curve
Isolation test voltage, V	$V_{\text{ISOL AC (RMS)}}$	100	10000	$\pm 1\%$ of reading $\pm 10\text{V}$	$I_{\text{ISOL}} = 0.1..5\text{mA}$;
	$V_{\text{ISOL DC}}$	100	12000	$\pm 1\%$ of reading $\pm 10\text{V}$	

IGBT Dynamic Test Equipment

Characteristic	Designator	Range		Accuracy	Conditions
Collector-emitter voltage after switching off, V	V_{CE}	20	2 800	According to the oscilloscope accuracy and resolution***	$V_{CC} = 20V..3400V;$ $V_{GEON} = 5..20V;$ $t_p = 5..1000\mu s;$
Peak collector-emitter voltage, V	$V_{CE(peak)}$	20	3 400		
Peak collector current, A	I_{CM}	500	2 500		
Turn-off energy, mJ	E_{off}	1	1 000		
Turn-on energy, mJ	E_{on}	1	1 000		
Turn-on delay time, ns	$t_{D(on)}$	10	10 000		
Rise time, ns	t_R				
Turn-off delay time, ns	$t_{D(off)}$				
Fall time, ns	t_F				
Tail time, ns	t_Z				
Reverse recovery time, ns	t_{RR}				
Decay current rate , A/us	di/dt	10	8 000		
Non-repetitive peak collector current, A	I_{CSM}	500	15 000		
Reverse recovery current , A	I_{RR}	500	4 000		
Reverse recovery charge , uC	Q_{RR}	1	3 000		
Reverse recovery energy, mJ	E_{REC}	1	1 000		
Decay recovery current rate , A/us	di_{REC}/dt	10	8 000		

Test types:

- Single pulse RBSOA
- Double (multiple) pulse RBSOA
- Short Circuit
- Avalanche Test

*** Scope device specification:

14 bit (0.006 %) resolution (16 bit enhanced resolution)
 500 MS/s sampling
 250 MHz bandwidth
 32 MSamples memory per channel
 0.25 % DC vertical accuracy, 0.1 % typical
 25 ppm time base accuracy

SiC Dynamic Test Equipment

Characteristic	Designator	Range		Accuracy	Conditions
Collector-emitter voltage after switching off, V	V_{CE}	100	1 700	According to the oscilloscope accuracy and resolution***	$V_{CC} = 20V..3400V;$ $V_{GEON} = 5..20V;$ $t_p = 5..1000\mu s;$
Peak collector-emitter voltage, V	$V_{CE(max)}$	100	2 000		
Peak collector current, A	I_{CPK}	50	6 50		
Turn-off energy, mJ	E_{off}	1	1 000		
Turn-on energy, mJ	E_{on}	1	1 000		
Turn-on delay time, ns	$t_{D(on)}$	20	10 000		
Rise time, ns	t_R				
Turn-off delay time, ns	$t_{D(off)}$				
Fall time, ns	t_F				
Tail time, ns	t_Z				
Reverse recovery time, ns	t_{RR}				
Decay current rate , A/us	di/dt	10	8 000		
Non-repetitive peak collector current, A	I_{CSM}	10	650		
Reverse recovery current , A	I_{RR}	20	650		
Reverse recovery charge , uC	Q_{RR}	0.1	3 000		
Reverse recovery energy, mJ	E_{REC}	1	1 000		
Decay recovery current rate , A/us	di_{REC}/dt	10	8 000		

*** Scope device specification:

14 bit (0.006 %) resolution (16 bit enhanced resolution)

500 MS/s sampling

250 MHz bandwidth

32 MSamples memory per channel

0.25 % DC vertical accuracy, 0.1 % typical

25 ppm time base accuracy

Clamping systems

Characteristic	Value				
	Module	Stud	Disk	Semiconductor element (bipolar)	Surge Current
Package type	Module	Stud	Disk	Semiconductor element (bipolar)	Surge Current
Type	Manual; Electromechanical	Manual; Electromechanical	Electromechanical	Electromechanical	Electromechanical
Force	2kN	2kN	100kN	100kN	150kN
Heating	150°C	150°C	200°C	200°C	200°C
Maximum current	6kA	6kA	30kA	30kA	120kA
Isolation	8kV	8kV	15kV	15kV	15kV
Form factor	Table housing	Table housing	19" Rack	19" Rack	19" Rack

Surge Current

Characteristic	Designator	Range		Accuracy	Conditions
Peak on-state voltage , V	$V_{TM(FM)}$	0.3	5	±1% of reading ±5mV	$I_{TM(FM)} = 400..15000A$; Signal shape: trapezoidal, sinus, s-curve Duration up to 10ms
Surge Current, kA	I_{SC}	0.5	40/80/120	±5% of reading	$V_{TM(FM)}$ up to 60V
Dimensions 40 kA type, mm	H x W x D	2200 x 800 x 1200			19" Rack
Dimensions 80 kA type, mm*	H x W x D	2200 x 1600 x 1200			19" Rack x 2
Dimensions 120 kA type, mm*	H x W x D	2200 x 2400 x 1200			19" Rack x 3

Power Cycling

Power supply: 1500A
Capacity: 5 modules (10 IGBTs)
19" Rack

HTRB

Power supply: 3000V, 1A
Temperature: up to 200°C
Capacity: 10 modules (20 IGBTs)
19" Rack

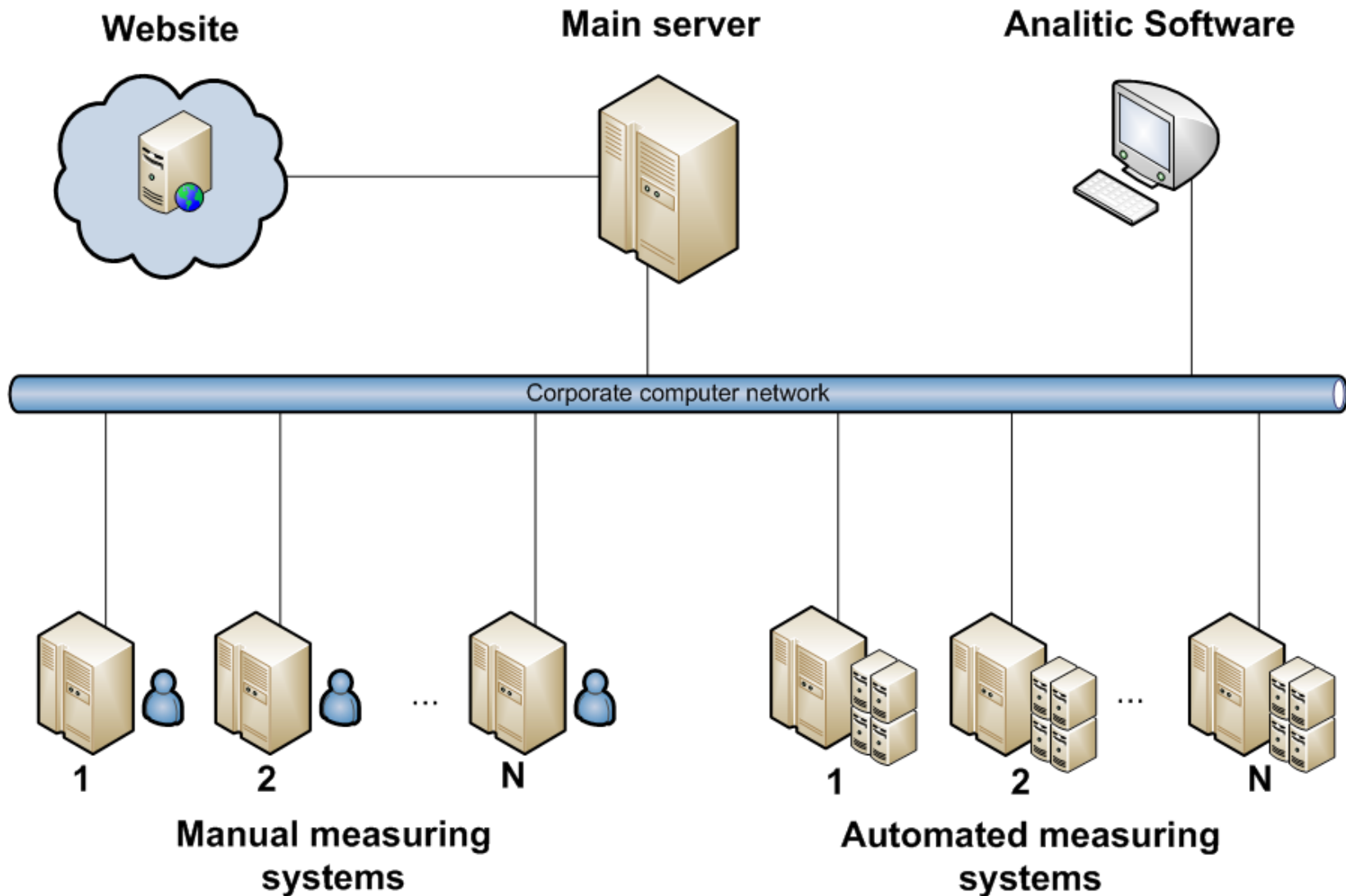
Zth

Main power supply: 1000A, 10ms-1000s
Pulse power supply: 2500A, 100us-10ms
Measuring current: 0.5A-5A 0.1%

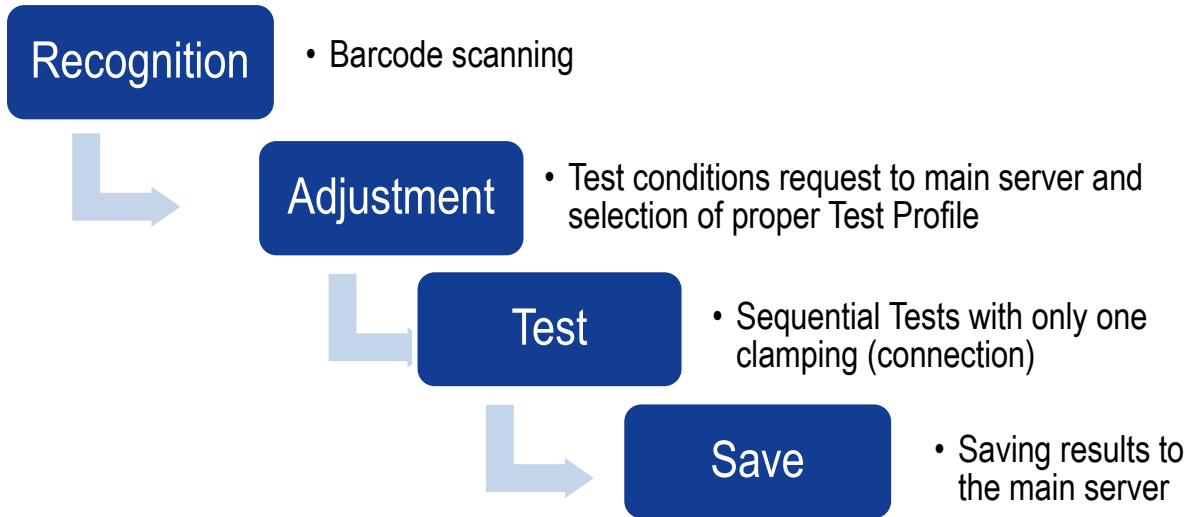
Equipment in production



Turn-key IT solution



Testing process



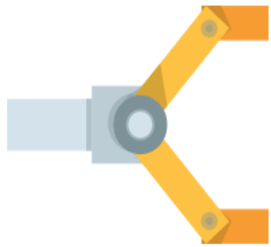
Turn-key IT solution advantages

- ✓ Centralized test profiles control
- ✓ Automatic equipment adjustment
- ✓ Centralized results storage



ATSM

ATSM – Automated Test System for power semiconductor Modules



- ✓ Fully automated test process
- ✓ All types of tests in one system (RT and Tjmax)
- ✓ Automatic DUT labelling (pass / reject)





Thank you!